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**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 2814**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki TOMIMATSU

Group Art Unit: 2814

Application No.: 10/782,810

Examiner: H. PHAM

Filed: February 23, 2004

Docket No.: 114371.01

For: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE  
SAME, CIRCUIT SUBSTRATE AND ELECTRONIC APPARATUS

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the January 12, 2006, Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**